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D-21,389

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Serial No.: 10/717,480

Group Art Unit: 3723

Inventors: Belov et al.

Filed: November 21, 2003

Title: HIGH SELECTIVITY
COLLOIDAL SILICON SLURRY

Examiner: E. A. Ojini

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. 1.51, 1.56 and 1.97(c), the list of references cited on the attached Form PTO-1449 is made of record to assist the Patent and Trademark Office in its examination of this application. A copy of each of the references cited are enclosed herewith. In accordance with the provisions of 37 C.F.R. § 1.97(c) and § 1.17(p) applicants have paid the requisite fee of \$180.00. This disclosure statement should neither be construed as a representation that a search has been made, nor as an admission that the information cited is, or is considered to be, material to patentability as defined in 1.56(b).

Respectfully submitted,

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Date: March 21, 2005

